

Notice of References Cited

Application/Control No.

10/754,493

Applicant(s)/Patent Under
Reexamination
HACKER ET AL.

Examiner

Yun H. Lee

Art Unit

3766

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,224,549	05-2001	Drongelen, Wim van	600/300
	B	US-			
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FOREIGN PATENT DOCUMENTS

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